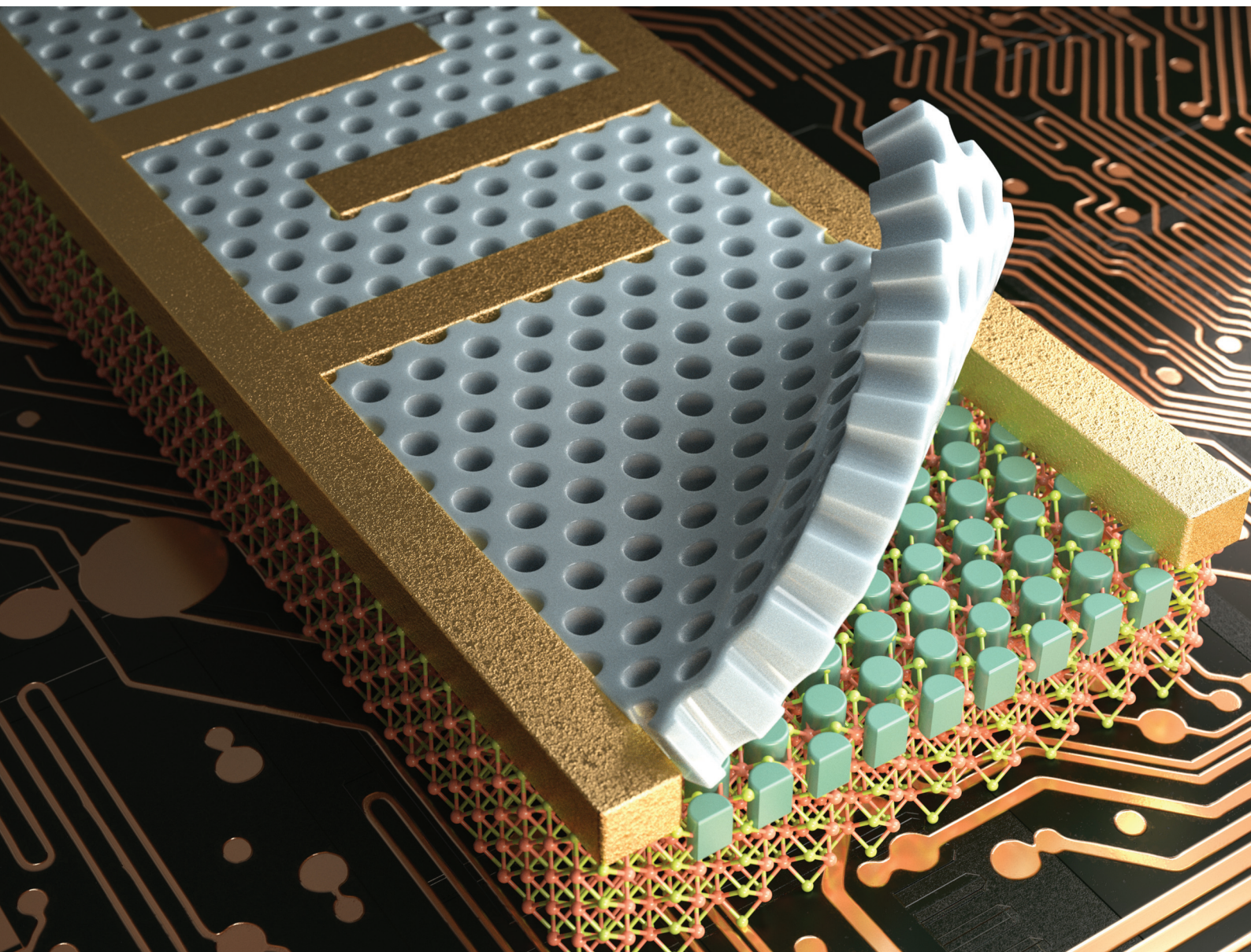


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Nanostructured doping of WSe₂ via block copolymer patterns and its self-powered photodetector application

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Transition metal dichalcogenides (TMDs), e.g., MoS₂, MoSe₂, ReS₂, and WSe₂, are effective materials for advanced optoelectronics owing to their intriguing optical, structural, and electrical properties. Various approaches for manipulating the surface of the TMDs have been suggested to unleash the optoelectronic potential of the TMDs. Herein, we employed the self-assembly of the poly(styrene-*b*-methyl methacrylate) (PS-*b*-PMMA) block copolymer (BCP) to prepare a nanoporous pattern and generate nanostructured charge-transfer p-doping on the WSe₂ surface, maximizing the depletion region in the absorber layer. After the spin coating and thermal annealing of PS-*b*-PMMA, followed by the selective etching of PMMA cylindrical microdomains using oxygen reactive-ion plasma, nanopatterned WO_x with high electron affinity was grown on the WSe₂ surface, forming a three-dimensional homojunction. The nanopatterned WO_x significantly expanded the depletion region in the WSe₂ layer, thus enhancing optoelectronic performance and self-powered photodetection. The proposed approach based on the nanostructured doping of the TMDs via BCP nanolithography can help create a promising platform for highly functional optoelectrical devices.

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Introduction

Two-dimensional (2D)-layered materials, also known as van der Waals (vdW) materials, exhibit excellent potential in optical sensing applications owing to their tunable band-gaps, strong light-matter interactions, chemical/mechanical stability, and defect-free surface.^{1–3} Transition metal dichalcogenides (TMDs), e.g., MoS₂, MoSe₂, ReS₂, and WSe₂, as promising optoelectronic materials have garnered attention owing to their unique electrical and optical characteristics, including thickness-dependent absorption coefficient and high carrier mobility, enabling fast and wavelength-selective photodetection for high-responsivity broad-band applications.^{4,5} In addition, TMD-based heterostructures, which are independent of lattice mismatches, allow versatile optoelectronic device architectures because heteroepitaxy in conventional semiconductors is restricted by the lattice constants between the neighboring layers.^{6,7} Among various TMDs, WSe₂, which exhibits ambipolar transport characteristics with decent hole (~250 cm² V⁻¹ s⁻¹) and electron (~270 cm² V⁻¹ s⁻¹) mobilities,

has been extensively investigated in the applications of field-effect transistors (FETs) and photodetectors owing to its large and tunable band-gap energy (monolayer (1.7 eV) and multilayer (1.2 eV)).^{8,9} A high-gain WSe₂ complementary metal oxide semiconductor (CMOS) inverter with localized charge transfer doping has been demonstrated.¹⁰ An infrared WSe₂-based photodetector with high sensitivity was reported with a vertical heterojunction structure between WSe₂ and black phosphorus.¹¹ To collect more electron-hole pairs (EHPs) efficiently generated by photon absorption, different device architectures have been proposed, including forming p-n homo-¹² or heterojunctions¹³ and integrating with quantum dots,⁵⁹ polymers,¹⁴ or perovskites.¹⁵

One of the challenges with TMDs is the development of facile and robust doping methods because conventional doping techniques, including high-temperature diffusion and high-energy ion implantation, are inappropriate for atomically thin layers.¹⁶ A controllable doping process in a semiconductor is a fundamental building block that helps construct p-n junctions, where a built-in electric field can separate photo-generated EHPs.^{17–19} As the exciton binding energy of the TMDs is relatively high, thermal energy is not sufficient to dissociate the bound excitons.^{20,21} Interestingly, the WO_x layer with high electron affinity can be natively grown in WSe₂, enhancing hole conductivity in the underlying WSe₂.^{22,23} Moreover, the ambipolarity of WSe₂ allows us to select the

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majority carrier type by applying electrostatic potential.⁸ Various oxidation methods, *e.g.*, thermal annealing under oxygen ambient conditions,²⁴ mild oxygen plasma treatment,²⁵ and laser-induced oxidation,¹² have been studied; these methods demonstrate versatile lateral and vertical junctions. The WO_x layer can also behave as a surface protection layer, which is critical to ensure the stability of electronic devices, as 2D-material-based electronic devices have suffered from air instability.²⁶

To further improve photon absorption, various surface treatments for TMDs have been introduced.^{27–31} Kim *et al.* demonstrated that the responsivity of MoS_2 phototransistors can be enhanced by the fabrication of nanopatterns on multi-layer (ML) MoS_2 TMDs using the self-assembly of block copolymers (BCPs).²⁷ BCPs are comprised of two or more chemically distinct polymers covalently bonded in a single chain and form various periodic nanostructures *via* microphase separation.^{32–41} In this case, the hexagonally packed nanoarrays of the BCPs provided abundant exposed edges, which were responsible for multiple trap states in the band-gap region, which is crucial for the photogating effect. Herein, we fabricated nano-dot arrays on ML WSe_2 FETs using the self-assembly of a cylinder-forming poly(styrene-*b*-methyl methacrylate) (PS-*b*-PMMA) BCP. The selective etching of the PMMA microdomains *via* O_2 reactive ion etching (RIE) oxidized WSe_2 to WO_x , leading to the p-doping of WSe_2 .³⁹ Consequently, the optoelectronic performance of ML WSe_2 FETs significantly improved. Moreover, it was confirmed that nanopatterned WSe_2 photodetectors can be operated without an external power source. The self-powered operation of a photodetector is favored because it is size-efficient and light. As the formation of the depletion region is critical to separate and collect photo-excited carriers, recent studies have been focusing on the construction of the depletion region using Schottky and p-n junctions. As Fermi-level pinning limits the engineering of Schottky barrier heights in TMDs, the formation of p-n homo-

or heterojunctions has been alternatively investigated. We introduced the nanostructured doping of WSe_2 using a single-step BCP nanolithography process, demonstrating the three-dimensional (3D) WSe_2 homojunction photodetector with self-powered photodetection capability.

Experimental details

Fabrication of WSe_2 TFTs

Fig. 1 shows the fabrication process of the self-powered WSe_2 photodetector with the nanostructured 3D junction. WSe_2 flakes were mechanically exfoliated from the bulk single crystal (purchased from HQ graphene) using the conventional Scotch tape method. The exfoliated WSe_2 flakes were dry-transferred onto a $\text{SiO}_2/\text{p}^+-\text{Si}$ substrate using a transparent polydimethylsiloxane film (Gel-Pak) and micromanipulator. The source and drain electrodes were defined on the WSe_2 flake using electron-beam lithography, and the Ti/Au electrodes (20/80 nm) were deposited using electron-beam evaporation. After the lift-off process, thermal annealing was performed under vacuum conditions (1×10^{-5} Torr) at 250 °C for 2 h to improve Ohmic behaviors and eliminate the bubbles trapped in the interface between the WSe_2 flake and the SiO_2 substrate.

Preparation of BCP nanoporous patterns

The PS-*b*-PMMA ($M_{\text{PS}} = 57 \text{ kg mol}^{-1}$, $M_{\text{PMMA}} = 25 \text{ kg mol}^{-1}$, $M_w/M_n = 1.07$) BCP was purchased from Polymer Source Inc. Meldrum's acid containing cross-linkable PS-*r*-PMMA random copolymers was synthesized using a previously reported method.⁴² It consists of styrene (52 mol%), MMA (45 mol%), and Meldrum's acid (3 mol%), and the total number average molecular weight was 24 kg mol^{-1} ($M_w/M_n = 1.13$).⁴² To obtain vertically oriented cylindrical nanopatterns on WSe_2 FETs, WSe_2 surfaces were neutralized with cross-linkable PS-*r*-PMMA random copolymers by spin-coating (3000 rpm, 45 s) 0.4 wt%

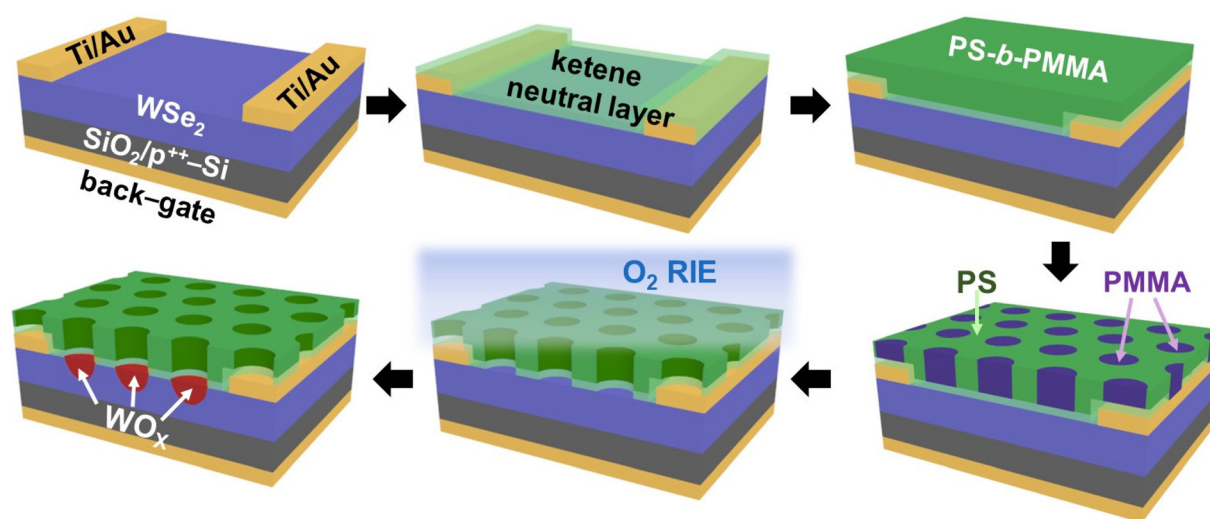


Fig. 1 Fabrication of the self-powered WSe_2 photodetector with the 3D nanostructured homojunction using the BCP nanolithography process.

toluene solution. Then, the PS-*r*-PMMA layer was thermally cross-linked at 230 °C for 1 h *in vacuo*. To prepare BCP films, 2 wt% toluene solution of PS-*b*-PMMA was prepared and spin-coated (3000 rpm, 45 s) on the WSe₂ substrate possessing a cross-linked neutral layer. Then, the BCP-coated WSe₂ FETs were thermally annealed at 210 °C for 24 h. To prepare nanoporous BCP templates, RIE was employed using O₂ with an RF power of 90 W at 20 sccm (Cute-1MP, Femto Science) to selectively remove PMMA microdomains and the underlying neutral layers. The etch rates were 0.81, 1.47, and 1.16 nm s⁻¹ for PS, PMMA, and the cross-linked PS-*r*-PMMA neutral layer, respectively.

Characterization

The thicknesses of the cross-linked PS-*r*-PMMA neutral layers and PS-*b*-PMMA BCP films were measured using spectroscopic ellipsometry (SE MG-1000, Nano-view Co.) at an incidence angle of 70.2° based on the Cauchy model. An atomic force microscope (AFM, Park Systems NX-10) was used to determine the thickness of the WSe₂ flakes and characterize the BCP nanopatterns on the WSe₂ surfaces. Phase and Z-height profile data were obtained with non-contact mode settings. A field emission scanning electron microscope (FE-SEM) (JSM-6700F, JEOL) was employed to investigate the nanoporous BCP pattern on the WSe₂ flake. The optical properties of the WSe₂ flake before and after BCP patterning were characterized using micro-Raman spectroscopy under the back-scattering geometry with a diode-pumped solid-state laser (Omicron) of 532 nm wavelength. The optoelectronic properties were determined

using a semiconductor parameter analyzer (Agilent 4155C) connected to a low-vacuum probe station (7.9 mTorr). The optical intensities of LED light sources (Newport) of 530 and 780 nm were calibrated using a power meter (FieldMaxII-TO, Coherent). An optical beam shutter (SHB1T, Thorlabs) connected to a pulse generator (Agilent 33250A) was used to analyze the time-dependent photoresponses of the fabricated photodetectors.

Results and discussion

To enhance the optoelectrical properties of the WSe₂ photodetector, nanoporous BCP patterns were prepared on the WSe₂ surfaces (Fig. 1). First, back-gated ML WSe₂ FETs were fabricated by transferring exfoliated WSe₂ flakes onto a SiO₂ substrate, followed by the deposition of Ti/Au electrodes. Then, cylinder-forming PS-*b*-PMMA BCP thin films were prepared on the WSe₂ surfaces with a film thickness of ~74 nm. To obtain nano-dot arrays, cylindrical PMMA microdomains need to be oriented perpendicularly to the substrate, and this can be accomplished using the ultrathin layer of the PS-*r*-PMMA random copolymer that neutralizes the WSe₂ surface.^{42–52} In this study, we employed a cross-linkable PS-*r*-PMMA random copolymer containing Meldrum's acid, which generates reactive ketenes upon heating and forms a cross-linked neutral layer.⁴² The BCP was spin-coated on the neutral layer and annealed at 210 °C. As shown in Fig. 2(c), hexagonally packed

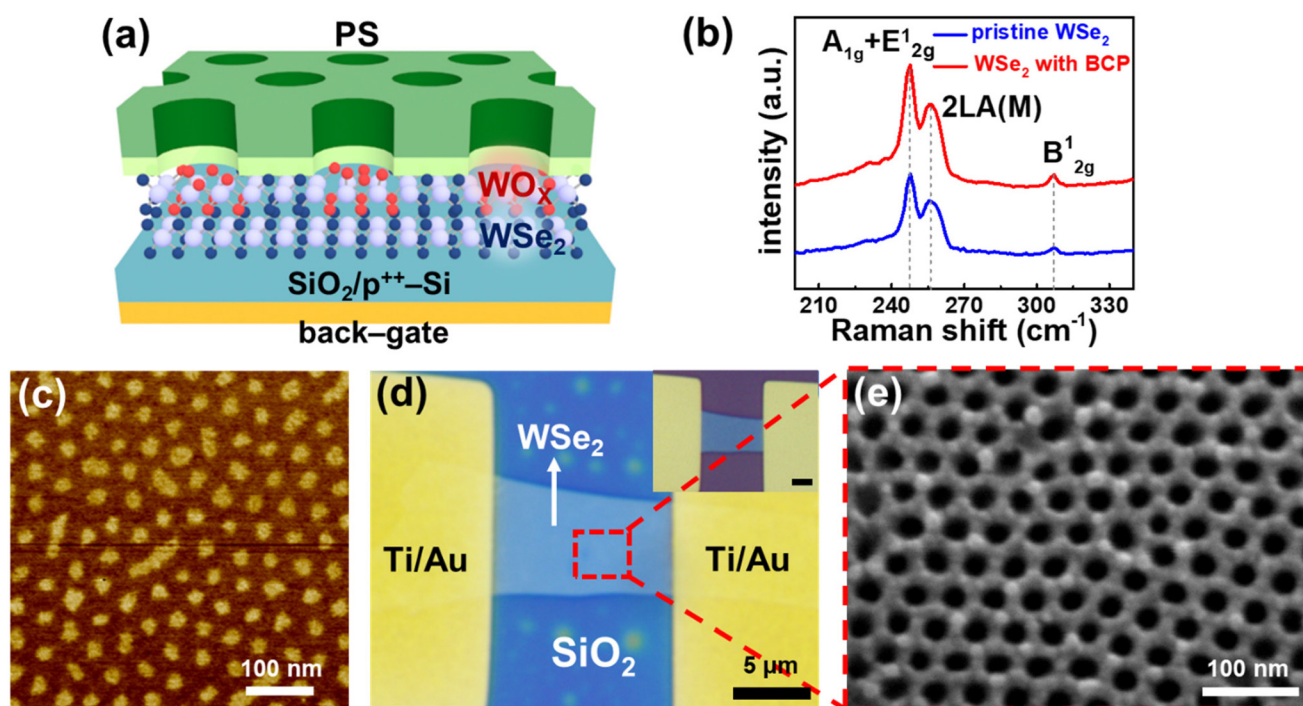


Fig. 2 (a) Schematic of the 3D WSe₂ homojunction with nanoporous PS. (b) Micro-Raman spectra of the pristine and BCP-patterned WSe₂. (c) AFM phase image of cylinder-forming PS-*b*-PMMA BCP thin films on the WSe₂ flake. (d) Optical microscopy of the WSe₂ photodetector. (e) SEM images of nanoporous BCP patterns on the WSe₂ photodetector.

nano-dot arrays are formed, indicating the vertically oriented PMMA cylinders. To generate nanoporous patterns, the PMMA microdomains were selectively removed using O_2 RIE with known etching rates of PS and PMMA (PS: 0.81 nm s^{-1} , PMMA: 1.47 nm s^{-1}). After the complete removal of PMMA and the underlying neutral layer, additional RIE was allowed for a few seconds to oxidize the exposed WSe_2 , creating nano-patterned WO_x embedded on the WSe_2 surface. As shown in Fig. 2(e), the average diameter of the nanopore is 28 nm with a domain spacing of 40 nm.⁵³

The oxygen plasma treatment during PMMA removal makes the underlying WSe_2 oxidized, forming the structure of WO_x/WSe_2 (Fig. 2(a)). As WO_x with a high work-function makes the neighboring WSe_2 electron-deficient, the underlying WSe_2 can be p-doped using the charge-transfer process.²³ The oxidation of WSe_2 has been intensively investigated using laser annealing,⁵⁴ oxygen plasma,⁵⁵ UV-ozone treatment,⁵⁶ and thermal annealing²⁴ under oxygen ambient conditions. Yang *et al.* effectively constructed seamless WSe_2 homojunction diodes by converting the top few layers of WSe_2 to WO_x ($x < 3$) via 325 nm laser exposure.⁵⁴ Moon *et al.* fabricated an oxidized WSe_2 FET with reduced channel resistance and a clean interface using the oxygen plasma treatment.⁵⁷ The oxidation of

WSe_2 , which is a self-limiting process, is initiated by substituting the Se vacancy with an oxygen atom; this is a spontaneous process with an enthalpy of -4.7 eV .⁵⁸ Micro-Raman spectroscopy confirms that the crystallinity of the underlying WSe_2 is well maintained after BCP patterning (Fig. 2(b)), although the oxidation process may create dangling bonds in the WSe_2 layer because the oxidation can proceed in the out-of-plane direction through the intrinsic defects. Fig. 2(d) shows the optical microscopy image of the ML WSe_2 photodetector possessing nanoporous BCP patterns. The SEM image of the nanoporous ML WSe_2 device indicates that the cylindrical PMMA microdomains are oriented perpendicularly to the WSe_2 surface, implying that the proposed single-step BCP nanolithography process is applicable for the post-fabrication process of TMD materials.

The current-voltage ($I_{DS}-V_{DS}$) characteristics of the nanoporous WSe_2 FETs at zero V_{GS} were compared under different illumination conditions as shown in Fig. 3(a) and (b). The low current levels can be attributed to the unwanted interface states and the non-optimization of the device layout. The EHPs were created using 530 and 780 nm wavelengths, generating photocurrents. The increase in the photocurrents was higher for the nanoporous WSe_2 FET owing to the formation of 3D

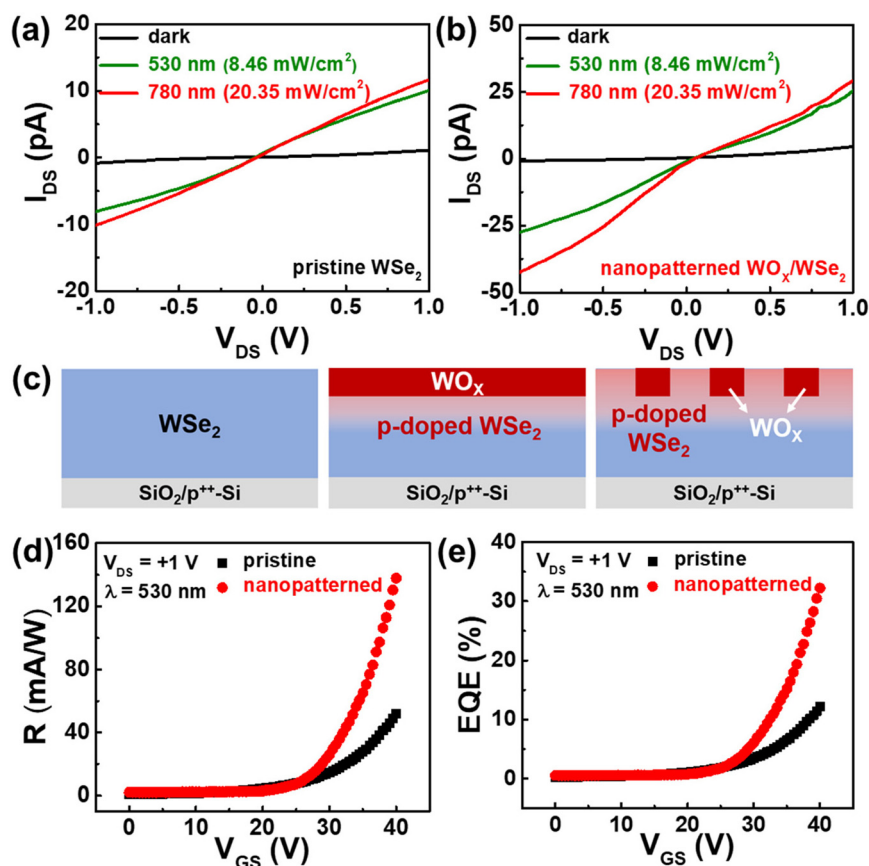


Fig. 3 Current-voltage characteristics of the (a) pristine and (b) nanopatterned WSe_2 device under different irradiation conditions (dark, and 530 nm and 780 nm wavelengths). (c) WSe_2 without a junction (left), WSe_2 with a planar junction (middle), and WSe_2 with a 3D nanostructured junction (right). (d) Responsivity (R) and (e) external quantum efficiency (EQE) at varying values of V_{GS} .

built-in electric fields (Fig. 3(c)). In pristine WSe₂, no electric fields exist, which is inefficient for collecting the generated EHPs under the exposure of light (Fig. 3c, left). Compared to the pristine one, the formation of layered WO_x can help develop 2D electric fields; it is a conventional method to form built-in electric fields (Fig. 3c, middle). In contrast, the nano-patterned BCP architecture can form 3D electric fields, which allows us to collect additional EHPs owing to the expansion of the depletion region (right side of Fig. 3(c)). The photons that were absorbed near and in the depletion region can help generate photocurrents.

Although the one-atom-thick TMD layer may achieve optimal electrical performance with a high on/off ratio and low power consumption, the lower optical absorption compared to the thick one limits its optoelectronic properties. As an alternative, the ML TMD layer is beneficial for optical absorbance. As the collection efficiency increases with the expansion of the depletion region, the photoresponse performances (responsivity (*R*) and external quantum efficiency (EQE)) were improved using the positive value of *V*_{GS} (Fig. 3(d) and (e)) under the illumination of 530 nm wavelength, implying the WO_x-induced p-doping of WSe₂. Operation in the increased depletion region under the appropriate gate bias caused the formation of the absorber layer, which is extremely sensitive to incoming photons through the channel. The optoelectronic parameters under the bias conditions of *V*_{DS} = +1 V and *V*_{GS} = 0 V are shown in Fig. 4(d). The responsivity (*R*) of the nanoporous WSe₂ photodetector was calculated using the following equation:

$$R = \frac{I_p}{A \cdot P},$$

where *I*_p denotes the photocurrent (defined as *I*_{illumination} − *I*_{dark}), *A* denotes the effective area, and *P* denotes the light power density. The external quantum efficiency (EQE) is defined by the following formula:

$$\text{EQE} = \frac{hc}{e\lambda} R,$$

where *h* denotes the Planck constant, *c* denotes the speed of light, and *λ* denotes the wavelength of the illuminated light. The detectivity (*D*^{*}) and photo-to-dark current ratio (PDCR) were obtained using the following equations:

$$D^* = \frac{RA^{0.5}}{(2q \cdot I_{\text{dark}})^{0.5}},$$

$$\text{PDCR} = \frac{I_{\text{illumination}} - I_{\text{dark}}}{I_{\text{dark}}} \times 100$$

where *q* denotes the electronic charge. The dynamic photo-response characteristics of WSe₂ photodetectors were compared with and without BCP nanopatterns. As shown in Fig. 4(a) and (b), time-dependent photocurrents were measured at varying intensities of 530 nm wavelength. The photocurrents increased with an increase in the light intensity, which indicates the high quality of the WO_x/WSe₂ structure (Fig. 4(c)). The optoelectronic performances significantly improved after BCP patterning on WSe₂ with fast response and decay characteristics. Persistent photoconductivity (PPC) was not observed, indicating that BCP patterning induced nominal defects in WSe₂. The self-powered photodetection mechanism of the nanoporous WSe₂ photodetector illustrated in Fig. 5(a) was demonstrated, where high photocurrents were obtained after BCP patterning (Fig. 5(b)). The negligible photocurrent

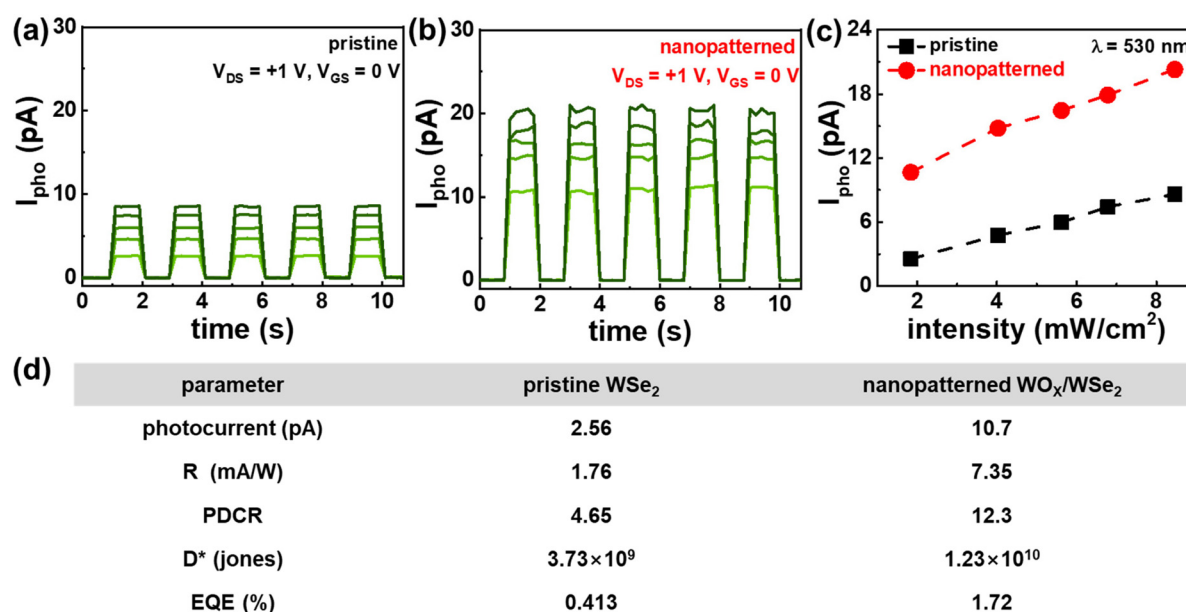


Fig. 4 Time-dependent photocurrent characteristics of the (a) pristine and (b) nanopatterned WSe₂ photodetector at varying optical intensities (530 nm wavelength). (c) Photocurrent at different optical intensities. (d) Optoelectronic parameters under the bias conditions of *V*_{DS} = +1 V and *V*_{GS} = 0 V considering the exposure of 530 nm with a light power density of 1.8 mW cm^{−2}.

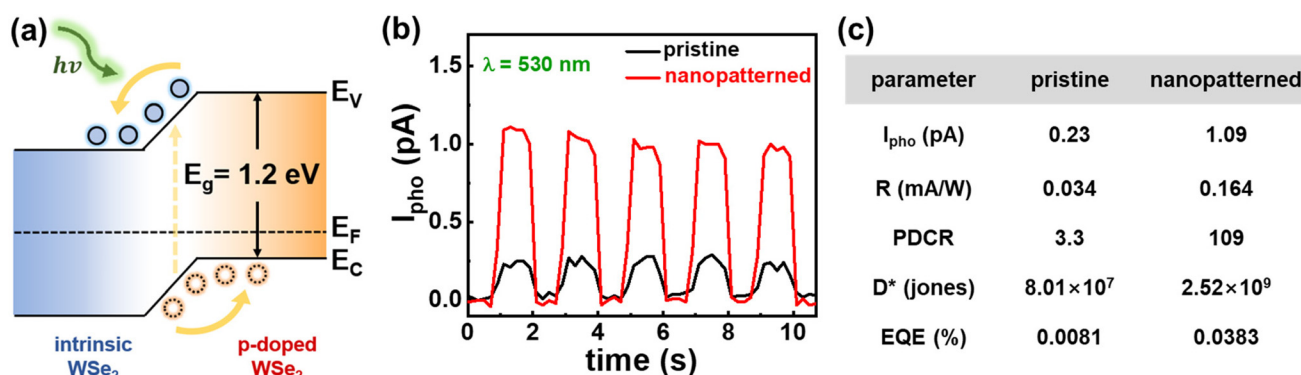


Fig. 5 (a) Mechanism of the self-powered WSe₂ photodetector. (b) Time-dependent photocurrent characteristics. (c) Optoelectronic performances of the pristine and nanopatterned WSe₂.

obtained from the pristine WSe₂ photodetector can be attributed to the non-ideal Ohmic contact with WSe₂ caused by Fermi-level pinning. The performance of the self-powered WSe₂ photodetector is illustrated in Fig. 5(c). Among the different methods to form built-in electric fields, including Schottky contacts, the p-n homojunction, and the p-n heterojunction, the p-n homojunction can be ideal because it nominally affects the absorber layer. Self-powered photodetectors can be miniaturized because they do not require external power sources.

Conclusion

A 3D homojunction was demonstrated in WSe₂ using a one-step BCP nanolithography process, enabling an effective collection of EHPs. The oxygen plasma used to remove PMMA cylindrical microdomains in PS-*b*-PMMA thin films oxidized the underlying WSe₂, forming a 3D WO_x/WSe₂ structure. The current-voltage output and transfer characteristics based on the fabricated WO_x/WSe₂ FET were obtained under dark and different illumination conditions, confirming the formation of built-in electric fields. The optoelectronic performances, including responsivity, PDCR, detectivity, and EQE, were significantly improved owing to the introduction of the multidimensional homojunction structure. There was no PPC at varying light power, implying a high-quality interface. Self-powered photodetection, which can operate without an external power source, was demonstrated with excellent static and dynamic photosensing performance. This study can provide a pathway for the development of high-performance stand-alone photodetectors based on the multidimensional device architecture.

Conflicts of interest

There are no conflicts to declare.

Acknowledgements

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